

Production of Glass Nozzles

Silke Grieser

Westfälische Wilhelms-Universität Münster, Institut für Kernphysik

PANDA Meeting Gießen, March 17th 2015



Bundesministerium
für Bildung
und Forschung



Laval nozzles for cluster-jet targets

Production of Laval nozzles

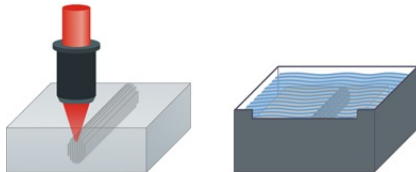
- Motivation for a new production process
 - Issue of the „previous“ production process
 - Laser technique provides connection between inlet and outlet zone of nozzle (narrowest inner diameter $> 40\text{ }\mu\text{m}$)
 - Precise drilling of the small inner diameter ($30\text{ }\mu\text{m}$)
 - Challenge: consistently drill



New Production Process of Nozzles

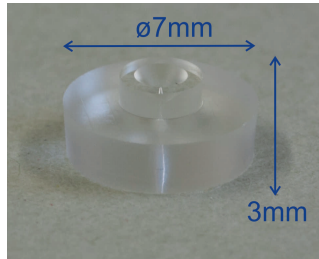
Selective laser etching

- Selective laser etching of glass by Lightfab
 - Ultra-short pulsed laser is focused within a transparent material, e.g., glass
 - Laser is only absorbed in the focal volume
 - There the optical and chemical properties of the material is changed
 - By moving the focus the areas can be selectively etched
 - ⚡ Only 3 mm in the depth possible (currently limited by optics)

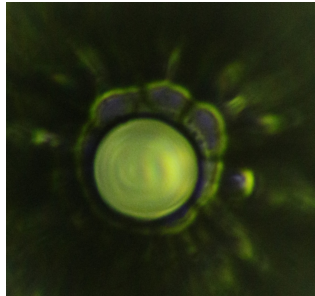


[LLT RWTH Aachen]

The New Nozzle

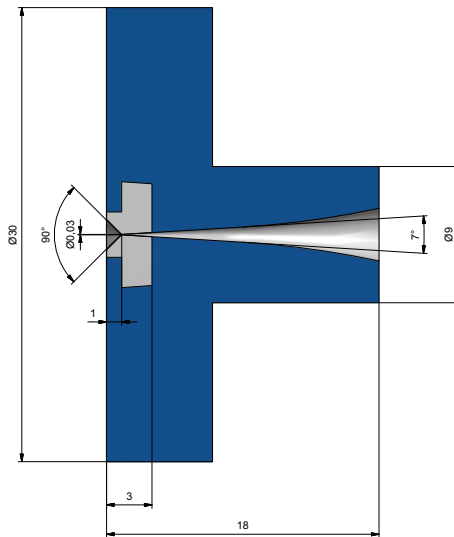


- Microscopic view of the narrowest inner diameter of about $30\text{ }\mu\text{m}$

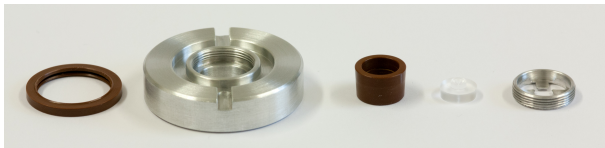


The New Nozzle

Comparison between the new glass nozzle and the other nozzles



Sealing of the New Nozzle



- Vespel[®] ring for sealing between nozzle adaptor and cold head
 - Aluminium ring to adapt the nozzle at the cold head geometry
 - Vespel[®] cylinder for sealing between nozzle and aluminium ring
 - New glass nozzle
 - Aluminium part to fix the glass nozzle in the nozzle adaptor
-
- Cooling test with 18 bar helium down to 19.5 K successful

Summary & Outlook

- A new Nozzle with an inner diameter of $30\text{ }\mu\text{m}$ was produced
- Successful sealing and cooling test down to 19.5 K
- Vespel[®] is an excellent alternative for indium for sealing (even by the CERN nozzles)
 - Accurate extraction, non-poisonous, reusable
- Initial measurements with new nozzles at the $\overline{\text{PANDA}}$ cluster-jet target prototype to prove the operation of these new nozzles